



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Nathan R. Brown

Serial No.: 10/715,248

Filed: November 17, 2003

For: POLISHING SYSTEMS FOR USE  
WITH SEMICONDUCTOR SUBSTRATES  
INCLUDING DIFFERENTIAL PRESSURE  
APPLICATION APPARATUS

Confirmation No.: 4988

Examiner: D. Thomas

Group Art Unit: 3723

Attorney Docket No.: 2269-4375.2US  
(99-1029.02/US)

Notice of Allowance Mailed:

November 10, 2004

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Person making Deposit: Steve Wong

Mail Stop ISSUE FEE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Sir:

Please amend the above-referenced application as follows:

AMENDMENT PURSUANT TO 37 C.F.R. § 1.312(a)